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Dated: June 12, 2006

Signature:

(Thomas A. Miller)

Atty. Docket No. 28944/50023



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE AS
DESIGNATED/ELECTED OFFICE

Applicant: Philippe Cormont, et al.)	Title: Method and Device for Lithography by Extreme Ultraviolet Radiation
Serial No.: 10/570,726)	Group Art Unit: To be assigned
Intl. Appl. No.: PCT/FR2004/002226)	Examiner: To be assigned
Intl Filing Date: 01 September 2004)	Filed: March 6, 2006

SUPPLEMENTAL PRELIMINARY AMENDMENT

Mail Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Prior to examination, please amend the accompanying application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 11 of this paper.